

Datasheet

SCIENTIFIC

Thermo Fisher

SE50A-ECO 300SF FT-IR Metrology Tool

For Material Characterization

Systems Engineering combines the Thermo Fisher Scientific's FT-IR measurement technology and JEL's sorter system to introduce a next generation "FT-IR SE50-ECO series" as semiconductor material characterization tools.

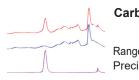
Application Specifications

Rang

 	r fra	

Epitaxial Thickness

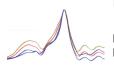
Range ▶ 0.3 - 750 µm Precision ► ± 0.01 µm * Epitaxial Thickness measurable.



Carbon & Oxygen in Silicon

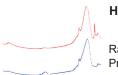
	Carbon	Oxygen [*]
е	▶ 0.1 to 10ppmA	▶ 0.3 to 35 ppmA
ision	►STD 0.05 ppmA	► STD0.08 ppmA

*All carbon and oxygen values reported using ASTM 1979 calculations.



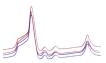
Boron & Phosphorus

Boron Phosphorus ▶ 1 - 10 Wt% ► 2 - 12 Wt% Range Precision ► ± 0.05 Wt% ► ± 0.05 Wt%



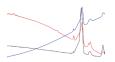
Hydrogen in Silicon Nitride

	Si-H	N-H
-	 ▶ 3 - 30 Atom% ▶ ± 0.3 Atom% 	



Fluorine in SiO₂ Films

Thickness ▶ 3000 - 10000Å Fluorine Concentration | > STD< 0.2 Fwt%

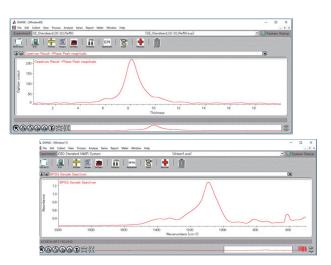


Carbon-doped Films

Silicon Nitride Silicon Oxide



Operation Software



- Intuitive Graphical User Interface
- Easy-to-Use operator and Authorized engineer user levels
- Easy to learn and use, giving optimum efficiency
- Measurement result, display and data logging.



Specifications

RELIABILITY			
MTBF	> 6 months		
MTTR	48 hours		
MTTS	4 hours		
Uptime	> 97%		

Computer Specifications				
Operation	Windows 10 64bit			
System	Memory 32GB			
	Hard Disk SSD RAID1			

OPTICAL		
Spectral Range		7800 - 350cm ⁻¹
Spectral Resolution		0.5cm ⁻¹
Beam Diameter		Standard 8mm (Variable)
Analysis Angle		15°
FACILITY R	EQURI	EMENIS
Power		100 - 240V
		(50/60Hz)
House Vacuum		-61±10kPa (G)
		30L/min (ANG)
Pressurized	CDA	0.52 - 0.6Mpa (G)
Gas	CDA	30L/min (ANR)
	N ₂	0.2MPa (G)
		15L/min (ANR)



SE50 Product Line

Hardware					Software	
Product#	Model	Wafer size	Station	Handring	Product#	Model
ECO-02S	SE50S-ECO	2-12 inch	Stage	Edge Grip	ECO-1EP	Epitaxial Thickness
ECO-031	SE50A-ECO 150SS	2-6 inch	Single	Vacuum	ECO-1CO	Carbon & Oxygen in Silicon
ECO-032	SE50A-ECO_150DS	2-6 inch	Double	Vacuum	ECO-1BP	Boron & Phosphorus in BPSG or PSG Films
ECO-041	SE50A-ECO_200SS	4-8 inch	Single	Vacuum	ECO-1SN	Hydrogen in Silicon Nitride
ECO-042	SE50A-ECO_200DS	4-8 inch	Double	Vacuum	ECO-1SF	Fluorine in Silicon Oxside Films
ECO-043D	SE50A-ECO_200DSMIF	8 inch	Double SMIF	Vacuum	ECO-1MB	Multi Background Option
ECO-044	SE50A-ECO_200FS	4-8 inch	Four	Vacuum	ECO-1GM	GEM/SECS Host Communication
ECO-051 ECO-052	SE50A-ECO_300SS SE50A-ECO_300DS	8-12 inch 8-12 inch	Single	Vacuum Vacuum	ECO-1SH ECO-1DS ECO-1FS	Share File Host Communication Double Station Sorting Support
ECO-051F	SE50A-ECO 300SF	8-12 inch	Single Foup	Vacuum	ECO-1FS ECO-1SS	Four Station Sorting Support Six Station Sorting Support
ECO-052F	SE50A-ECO_300DF	8-12 inch	Double Foup	Vacuum	ECO-10H	Hydrogen in Silicon Software
ECO-051E ECO-052E ECO-051FE ECO-052FE THZ-02	SE50A-ECO_300SSE SE50A-ECO_300DSE SE50A-ECO_300SFE SE50A-ECO_300DFE SE50A-THz_150DS	12 inch 12 inch 12 inch 12 inch 4-6 inch	Single Double Single Foup Double Foup Double	Edge Grip Edge Grip Edge Grip Edge Grip Vacuum	ECO-1SC ECO-1SU ECO-1CH ECO-1SO Option	SiC Epitaxial Thickness Support Shuttle Background Software Carbon-doped Films Silicon Oxiside Film Analysis (SiXx)
THZ-04	SE50A-THz_150FS	4-6 inch	Four	Vacuum	Product#	Model
THZ-06	SE50A-THz_150SiS	4-6 inch	Six	Vacuum	ECO-FA1	200mm wafer adapter for FOUP system
					ECO-FA2	Tag Reader for FOUP & SMIF system

Grip	ECO-1SC	SiC Epitaxial Thickne
Grip	ECO-1SU	Shuttle Background S
Grip	ECO-1CH	Carbon-doped Films
Grip	ECO-1SO	Silicon Oxiside Film A
n	Option	
n	Product#	Model
n	ECO-FA1	200mm wafer adapte
	ECO-FA2	Tag Reader for FOUF • Keyence : BL600 • Omron : V640
	ECO-FA2	Keyence : BL600
		 Keyence : BL600 Omron : V640
	ECO-FA3	Keyence : BL600 Omron : V640 E84 OHT Support for 0

	• Onnon . vo40
ECO-FA3	E84 OHT Support for OHT COM module
ECO-FA4	Safety Light Curtain for OHT
ECO-FA5	Sensing lonizer System
ECO-FA6	Water ID Reader Module
ECO-FA7	Optical FFU (Fan Filter Unit)

Optical FFU (Fan Filter Unit) ECO-FA8 Share File Host Communication

Systems Engineering

Head Office Factory West Branch

: 1-4-12 Koishikawa Bunkyo-ku, Tokyo 112-0002 Japan : 3-5-8 Funado Itabashi-ku, Tokyo 174-0041 Japan

: Miyahara Yodogawa-ku Oosaka-shi, Oosaka 532-0003 Japan TEL +81-6-6868-9790 FAX +81-6-6868-9796

TEL +81-3-3868-2634 FAX +81-3-3868-2633 TEL +81-3-6279-8908 FAX +81-3-6279-8907

Made in Japan